

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 28, 2024

IGI Report Number

LG667414670

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

11.15 X 8.24 X 5.66 MM

GRADING RESULTS

Carat Weight

5.09 CARATS

Color Grade

G

Clarity Grade

SI 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG667414670

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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
Symmetry

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Fluorescence

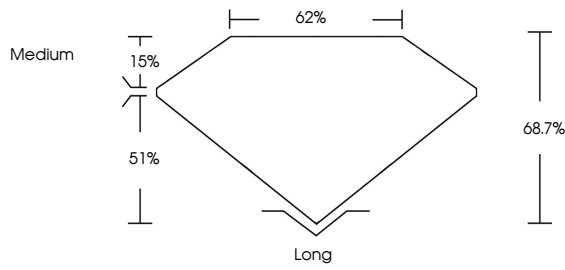
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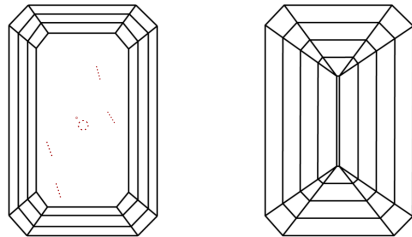
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY


IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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EMERALD CUT

11.15 X 8.24 X 5.66 MM

Carat Weight

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SI 1

Depth

68.7%

Table

62%

Graile

Medium

Culet

Long

Polish

EXCELLENT


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